

DOCKET NO: 247814US90CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YASUJI HIRAMATSU, ET AL. : ATTN: APPLICATION DIVISION
SERIAL NO: NEW CONTINUATION APPLN. :
(Based on 09/926,464)
FILED: HERewith :
FOR: CERAMIC SUBSTRATE FOR A :
SEMICONDUCTOR :
PRODUCING/EXAMINING DEVICE :

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified Continuation application of 09/926,464 as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.